#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re the Application of: Miwa KOZAWA et al.

Group Art Unit: 1644

Serial No.: 10/629,806

Examiner: Unassigned

Filed: July 30, 2003

Confirmation No.: 2495

For: RESIST PATTERN THICKENING MATERIAL, PROCESS FOR FORMING RESIST PATTERN, AND PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE

Attorney Docket No.: 030923 Customer Number: 38834

### INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

March 26, 2004

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO-1449. A copy of each listed document is attached.

No fee or certification is required in connection with this Information Disclosure Statement, because it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. Applicants respectfully request that the information be expressly considered during the prosecution of this application and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

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The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee that is required to effect consideration of this statement.

Respectfully submitted,

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Attachments: USPTO-1449

16 References

European Search Report

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INFORMATION **DISCLOSURE CITATION** PTO-1449

Atty. Docket No. 030923

Serial No. 10/629,806

Applicant(s): Miwa KOZAWA, et al.

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Group Art Unit:

# **U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	U.S. 0,037,476A1	КАМІЈІМА	3/28/2002	430	311	February 23, 2001
	U.S. 6,319,853 B1	ISHIBASHI	11/20/2001	438	780	March 29, 2000
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#### FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation (Yes or No)
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	X	06,003,824	1/14/1994	JP	Abstract
	*	04,178,648	6/25/1992	JP	Abstract
		EP 1 343 052 A2	1/16/2003	EP	-
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		DE 100 14 083 A1	3/22/2001	DE	No
		DE 198 43 179 A1	7/22/1999	DE	No
		WO 02/10,858 A3	2/7/2002	Int'l	-
		WO 03/014830 A1	2/20/2003	Int'l	-

# **OTHER DOCUMENTS**

	European Search Report dated January 29, 2004	
Examiner	Date Considered	